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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**  
(211.001-D1-US)

In re Application of: **FAZAN ET AL.**

Serial No: **10/694,689**

U.S. Filing Date: **OCTOBER 28, 2003**

Title: **SEMICONDUCTOR DEVICE**

) Group Art Unit:

) Examiner:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 29, 2004

Date

Michiko Sites

(person signing this certificate)

Michiko Sites

Signature

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**THIRD PRELIMINARY AMENDMENT**

Dear Sir:

Prior to the examination of the above-referenced application, kindly amend the application as follows: